



Attorney Docket No. 0756-2422

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Hideto OHNUMA

Serial No. 10/053,572

Filed: January 24, 2002

For: METHOD OF MANUFACTURING  
SEMICONDUCTOR DEVICE

) Group Art Unit: 2812

) Examiner: J. Kennedy

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is being  
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*Adelle M. Stampen*

AMENDMENT

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated October 31, 2003, please consider the following amendments and remarks in connection with the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 11 of this paper.